



S&H Form: (2/01)
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Kimitaka MURASHITA

Application No.: 10/028,264

Group Art Unit: 2802

Confirmation No.: 2737

Filed: December 28, 2001

Examiner: Scott Rogers

For: DISPLAY MEASURING METHOD AND PROFILE GENERATING METHOD

RESPONSE TO RESTRICTION REQUIREMENT

RECEIVED

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

MAY 17 2004

Technology Center 2600

Sir:

In response to the Office Action mailed April 21, 2004, applicant elects Claims 1-7 and 28-30 of Group A, without traverse.

Respectfully submitted,

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Date: 5/11/04

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